Application No.	Applicant(s)
10/050.597	YAMAZAKI ET AL.
Examiner	Art Unit
Jennifer M. Dolan	2813
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	Examiner Jennifer M. Dolan ars on the cover sheet wite (OR REMAINS) CLOSED in for other appropriate communication is sand MPEP 1308. Examiner. der 35 U.S.C. § 119(a)-(d) of the communication to file the communication to file entraceived in Application. In the communication to file entraceived in Application. It do Note the attached EXA is reason(s) why the oath or the besubmitted. In the communication to file entraceived in Application. It do Note the attached EXA is reason(s) why the oath or the header according to 37 CF (Sit of BIOLOGICAL MATE FOR THE DEPOSIT OF BIOLOGICAL MATE FOR THE DEPOSIT OF BIOLOGICAL MATE (Sit of BIOLOGICAL MATE FOR THE DEPOSIT OF BIOLOGICAL MATE (Sit of BIOLO

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DETAILED ACTION

This action is in response to the Amendment filed 6/24/04

Allowable Subject Matter

- 1. Claims 1-22, 24-30, 32-38, and 40-68 are allowed.
- 2. The following is an examiner's statement of reasons for allowance: Regarding claims 1, 2, 4-6, and 8, the primary reason for allowance is that the claim language requires that a pixel electrode and a storage capacitor be formed over an interlayer insulating film covering a thin film transistor, and that the pixel electrode and capacitance wiring line are formed on the same interlayer insulating film. The prior art typically teaches the placement of a capacitor structure at a same level as the TFT, and thus well below the level of the pixel electrode (see, for example, U.S. Patent No. 6,521,913 to Murade) or above the TFT, but still below the level of the pixel electrode (see U.S. 6,495,886 and 6,490,014). It is the examiner's opinion that placement of such features as the pixel electrode and storage capacitor wiring lines is highly critical, since the specific placement affects crucial parameters, such as the pixel aperture ratio, the leakage current, the total storage capacity, and the fabrication complexity of the pixel, and thus, the specific placement is not arbitrary or obvious without a specific prior art suggestion of such. Since the prior art fails to specifically teach a pixel having the capacitor and pixel electrode configuration specified in the claims, and since such an arrangement provides simpler fabrication complexity by permitting the pixel electrode and one capacitor line to be formed from the same

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film, as well as maintaining a favorable aperture ratio and storage capacity, it is the examiner's opinion that such a configuration would not have been obvious to a person skilled in the art.

Claims 9-22, 24-30, 32-38, and 40-68 were allowed in the office actions of 4/10/03, 11/26/03, and 3/24/04.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jennifer M. Dolan whose telephone number is (571) 272-1690. The examiner can normally be reached on Monday-Friday 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl W. Whitehead, Jr. can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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